

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Akihiko ENDO et al. Mail Stop PCT  
Appl. No. : Not Yet Assigned (U.S. National Phase of PCT/JP2004/013070)  
I. A. Filed : September 8, 2004  
For : SOI WAFER AND ITS MANUFACTURING METHOD

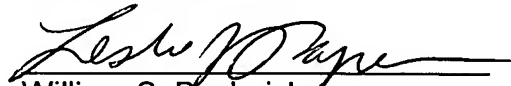
**CLAIM OF PRIORITY**

Commissioner for Patents  
U.S. Patent and Trademark Office  
Customer Service Window, Mail Stop PCT  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

Applicant hereby claims the right of priority granted pursuant to 35 U.S.C. 119 and 365 based upon Japanese Application No. 2003-315990, filed September 8, 2003. The International Bureau already should have sent a certified copy of the Japanese application to the United States designated office. If the certified copy has not arrived, please contact the undersigned.

Respectfully submitted,  
Akihiko ENDO et al.

  
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March 3, 2006  
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